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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	
				Filing Date	
				First Named Inventor	Manfred Albrecht
				Art Unit	
				Examiner Name	
Sheet	1	of	2	Attorney Docket Number	HSJ920030214US1

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Examiner Signature		Date Considered	
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**INFORMATION DISCLOSURE
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Sheet

2 of 2

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Application Number	
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First Named Inventor	Manfred Albrecht
Group Art Unit	
Examiner Name	
Attorney Docket Number	HSJ920030214US1

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
		R. L. White et al., "Patterned Media: A Viable Route to 50 Gbit/in ² and Up for Magnetic Recording?", IEEE Transactions on Magnetics, Vol. 33, No. 1, January 1997, 990-995	
		C. Chappert, et al., "Planar Patterned Magnetic Media Obtained by Ion Irradiation," Science, Vol. 280, June 19, 1998, pp. 1919-922	
		E. Eleftheriou et al., "Millipede-A MEMS-Based Scanning-Probe Data-Storage System", IEEE Transactions on Magnetics, Vol. 39, No. 2, March 2003, pp.938-945	
		M. Kleiber et al., "Magnetization switching of submicrometer Co dots induced by a magnetic force microscope tip", Phys Rev B, Vol. 58, No. 9, 1 September 1998, pp. 5563-5567	
		J. Lohau et al. "Writing and reading perpendicular magnetic recording media patterned by a focused ion beam", Appl Phys Lett, Vol. 78, No. 7, 12 February 2001, pp. 990-992	
		B. Cui et al. "Perpendicular quantized magnetic disks with 45 Gbits on a 4x4 cm ² area", J Appl Phys, Vol. 85, No. 8, 15 April 1999, pp. 5534-5536	
		Haginoya C. et al., "Thermomagnetic writing on 29 Gbit/in.(2) patterned magnetic media", APPL PHYS LETT 75 (20): 3159-3161 NOV 15 1999	
		Castano F. et al., "Magnetic force microscopy and x-ray scattering study of 70x550 nm(2) pseudo-spin-valve nanomagnets", J APPL PHYS 93 (10): 7927-7929 Part 3 MAY 15 2003	
		Todorovic M., "Writing and reading of single magnetic domain per bit perpendicular patterned media", APPL PHYS LETT 74 (17): 2516-2518 APR 26 1999	
		Ross C., "Patterned magnetic recording media", ANNU REV MATER RES 31: 203-235 2001	
		A. Dietzel et al., "Ion Projection Direct Structuring for Patterning of Magnetic Media", IEEE Transactions on Magnetics, Vol. 38, No. 5, September 2002, pp. 1952-195	

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